June 14–18, 2020 / Budapest, Hungary

Budapest, November 4, 2019

**ICTF: JVC** 2020

www.ictf-jvc.com

Dear Colleagues,

It is our pleasure to welcome you to join the 18<sup>th</sup> International Conference on Thin Films (ICTF) which will be organized jointly with 18<sup>th</sup> Joint Vacuum Conference (JVC) in Budapest, Hungary. The conference will be held from 14<sup>th</sup> to 18<sup>th</sup> June 2020 at the ELTE University Congress Center, which is located in the fast growing and modern South-Buda side of Budapest.

The ICTF is one of the tri-annual conference series endorsed and co-organized by the Thin Film Division of the International Union for Vacuum Science, Technique and Applications (IUVSTA). JVC is the meeting of the established series of Joint Vacuum Conferences, which are organized at two-year periods by the Austrian, Croatian, Czech, Hungarian, Slovak and Slovenian national vacuum societies.

The registration and abstract submission are open now. For more details regarding the conference, please visit conference website, which is continuously updated with new information.

Conference home page - <u>https://ictf-jvc.com/</u> On-line registration - <u>https://e-conf.com/ictf-jvc2020/registration/</u>

The conference will consist of plenary, invited and oral presentations as well as posters.

The scientific program of the conference will cover following topics:

- Applied Surface Science
- Biointerfaces
- Plasma Science & Technique
- Surface Engineering
- Surface Science
- Thin Films; Including:
  - - Thin film growth mechanism and models, new approaches
  - - Thin film multilayer and superlattices
  - o Semiconductor, dielectric, ferroelectric & piezoelectric thin films
  - - Magnetic, superconducting and multiferroic thin films
  - - Thin films for optoelectronics, nanoelectronics, spintronics and batteries
  - Thin film solar cells: inorganic, organic, perovskites etc.
  - - Thin film sensors & actuators
- Vacuum Science & Technique
- Electronic Materials and Processing
- Nanometer Structures

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## Important dates

- Abstract submission deadline: February 15, 2020
- Early bird registration deadline: March 15, 2020

All your questions and detailed information requests please send to the e-mail address: <u>ictf-jvc@akcongress.com</u>

If you have any questions about the conference, please do not hesitate to contact us.

Please feel free to forward this email to any of your colleagues who might be interested in this event.

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We are looking forward to seeing you at the ICTF-JVC2020 conference!

On behalf of the organizers,

Prof. József Gyulai, *Chair of the Conference* Dr. Béla Pécz, *Co-Chair of the Conference* Dr. Attila Csík, *Chair of the LOC*